

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application		OFGS File No. 711/585289			
		Applicant Takeshi NAKAMURA					
		Filing Date		Group Art Unit			
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
/CT/	US-2001/0008067 A1	07-2001	Liebig	60	39.02		
/CT/	US-6,368,663 B1	04-2002	Nakamura et al.	427	248.1		
	US-						
FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
/CT/	JP 10-194856	07-1998	Japan			abstract	
/CT/	P2003-20287	01-2003	Japan			abstract	
/CT/	EP 1 277 716 A1	01-2003	Europe				
/CT/	63-012671	01-1988	Japan			abstract	
/CT/	P2000-219576	08-2000	Japan			abstract	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
/CT/	International Search Report PCT/JP2004/019518 dated 29 March 2005						
Examiner		/Camie Thompson/					
		Date Considered 04/07/2008					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							